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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/082,599

Confirmation No. .... 5736

Filing Date ..... February 22, 2002

Inventor ..... Craig M. Carpenter et al.

Assignee..... Micron Technology, Inc.

Group Art Unit..... 1763

Examiner ..... Karla A. Moore

Attorney's Docket No. .... MI22-1941

Customer No. .... 021567

Title: Interfacial Structure for Semiconductor Substrate Processing  
Chambers and Substrate Transfer Chambers and for Semiconductor  
Substrate Processing Chambers and Accessory Attachments, and  
Semiconductor Substrate Processor

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GROUP 1700

**RESPONSE TO AUGUST 14, 2003 OFFICE ACTION**

To: Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**VIA U.S. EXPRESS MAIL**

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
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Spokane, WA 99201-3828

Responsive to the Office Action dated August 14, 2003, Applicant  
amends and remarks as follows:

**AMENDMENTS**